

Abstract

Provided is a film bonding method suitable for achieving a narrower bezel in an image display apparatus. The film bonding method of the present invention is a film bonding method for bonding a sensor film and an optical film to each other, one surface of the sensor film having arranged thereon an electrode and a lead wire connected to the electrode, the method including: performing registration of the optical film with reference to the lead wire; and bonding the sensor film and the optical film to each other.

FIG. 3